



PATENT
97-CT-174

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
RAFFAELE ZAMBRANO)	Group Art Unit: 2823
Serial No.: 09/191,743)	
Confirmation No.: 8970)	Examiner: M. Estrada
Filed: November 13, 1998)	
For: IN-SITU DEPOSITION AND)	
DOPING PROCESS FOR POLY-)	
CRYSTALLINE SILICON LAYERS)	
AND THE RESULTING DEVICE)	
_____)	

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 1, 2003, the due date for response to which has been extended to February 2, 2004 (the first business day after February 1, 2004) by the enclosed petition for extension of time, in connection with the above-identified application, please enter and consider the following amendment and remarks.

I hereby certify that this correspondence is
being deposited with the United States Postal
Service with sufficient postage as first class
mail in an envelope addressed to:
Commissioner for Patents, P.O. Box 1450,

Alexandria, VA 22313-1450, on 2/2/04
Date of Deposit

Stephen Bongini
Applicant, Assignee, or Representative

Stephen Bongini 2/2/04
Signature Dated

02/13/2004 CNGUYEN 00000004 501556 09191743

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